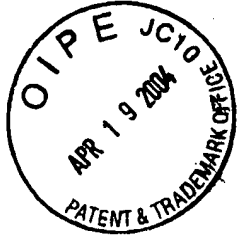


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Docket No. F-7041

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Kiyohiko TAKAGI, et al.  
Serial No. : 09/892,023  
Filed : June 26, 2001  
For : DRYING ETCHING METHOD  
Group Art Unit : 2823  
Examiner : William D. Coleman  
Confirmation No. : 1827  
Customer No. : 000028107

**Certificate of Mailing Under 37 CFR 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on April 14, 2004.

Lawrence I. Wechsler  
(Name)

*James D. [Signature]*  
(Signature)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

04/21/2004 SDENBOB1 00000001 101250 09892023  
01 FC:1252 420.00 DA

Docket No. F-7041

Ser. No. 09/892,023

**INTRODUCTORY COMMENTS:**

Sir:

In response to the Office Action of November 14, 2003, please amend the above-identified patent application as follows: